

1110/90738

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicants: Satoshi Komiya et al.

Serial No.: 10/679,031

Filed: October 3, 2003

For: EPITAXIAL SILICON WAFER

Examiner: Matthew J. Song



) Art Unit: 1765

) Confirmation No.: 1669

) I hereby certify that this correspondence is being
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) AMENDMENT, Commissioner for Patents, / P.O. Box
) 1450, Alexandria, Virginia 22313-1450, on
) September 9, 2005

) 

) Gerald T. Shekleton Reg. No. 27,466

AMENDMENT

Mail Stop: AMENDMENT
Commissioner for Patents
P.O. Box 1450
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Sir:

The Office Action of March 15, 2005 has been carefully reviewed and the following amendments and remarks are made in response thereto.

09/14/2005 MWOLDGE1 00000018 10679031

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02 FC:1201

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